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Docket: 0756-1614

Date: December 30, 1996

## N THE UNITED STATES PATENT AND TRADEMARK OFFICE

## REQUEST FOR FILE WRAPPER CONTINUING APPLICATION UNDER 37 CFR 1.62

Honorable Assistant Commissioner for Patents Box FWC Washington, D.C. 20231

Sir:

This is a Request for filing a

[X] Continuation [] Divisional

under 37 CFR 1.62 of prior pending application

Serial No. 08/519,420

Art Unit: 1112

Filed: August 25, 1995

Examiner: M. Padgett

Entitled: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE.

by the following named inventors:

Takeshi FUKUNAGA

Hisashi OHTANI

## Akiharu MIYANAGA

The above identified prior application in which no payment of the issue fee, abandonment of, or termination of proceedings has occurred, is hereby expressly abandoned as of the filing date of this new application. Please use all the contents of the prior application file wrapper, including the drawings, as the basic papers for the new application. (Note: 37 CFR 1.60 may be used for applications where the prior application is not to be abandoned.)

- 1. [X] To the best of information and belief, the current correspondence address of the inventors is as set forth in the Declaration filed in the parent application.
- 2. [X] Enter the amendment previously filed in the prior application on December 3, 1996 under 37 CFR 1.116, but unentered.
- 3. [X] A preliminary amendment is attached.
- 4. The filing fee is calculated on the basis of the claims existing in the prior application as amended at 2 and 3 above.

	No. Filed		No. Extra	Rate Sm/Lg Entity	Fee
For:	NO. 1 lied			\$385/770	\$770.00
Basic Fee		- 20	1	x 11/22	\$ 22.00
Total Claims	21	- 20	<u> </u>		
Independent Claims	8	- 3	5	x 40/80	\$400.00
First presentation of multiple dependent claims \$130/260					\$1,192.00
Total					\ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \

5. [ ] Amend the specification by inserting before the first line, the sentence:

This application is a Continuation of Serial No. 08/519,420, filed

August 25, 1995, now abandoned.

6. [X] A check in the amount of \$1,302.00 is enclosed. Includes extension of time for one month.

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7. [ ] The small entity status established in the parent application continues to be applicable and such small entity status is hereby requested for the present application.

8. [X] Priority is claimed under 35 USC 119 based on foreign application(s)
No.(s) 6-225851

Filed in (country) Japan

On (date): August 26, 1994

- [ ] Certified copy (copies) attached.
- [X] Certified copy (copies) filed on <u>August 25, 1995</u> in prior United States Serial No. <u>08/519,420</u> filed on <u>August 25, 1995</u>.
- 9. [X] The prior application is assigned of record to <u>Semiconductor Energy</u> <u>Laboratory Co., Ltd.</u>.
- 10. [X] The power of attorney in the prior application is to:

Reg. No. 20,932
Reg. No. 24,312
Reg. No. 26,477
Reg. No. 23,016
Reg. No. 27,997
Reg. No. 28,290

- 12. [X] The Commissioner is hereby authorized to charge fees under 37 CFR
   1.16 and 1.17 (except the issue fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380.
   A <u>duplicate</u> of this form is attached.
- 13. [X] It is hereby petitioned under 37 CFR 1.136 that the response term in the prior pending application be extended, if necessary, to a date which includes the filing date of the present application, and the Commissioner is hereby authorized to charge any necessary extension fee to Deposit Account No. 19-2380. The prior pending application is hereby expressly abandoned upon the award of a filing date to this application.

14. [X] Also enclosed:

Petition for Extension of Time

Address all future correspondence to:

SIXBEY, FRIEDMAN, LEEDOM & FERGUSON, P.C.

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McLean, Virginia 22102

(703) 790-9110

Respectfully submitted,

Gerald J. Ferguson, Jr.

Registration No. 23,016

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